

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No: 09/890,550 Confirmation No. 4691

Applicant: MAJIMA et al.

Filed: January 14, 2002

Group Art Unit: 1771

Examiner: VO, HAI

Attorney Docket No: 2000-22

Customer No.: 30448

For: POROUS SILICON CARBIDE SINTER AND SILICON CARBIDE-METAL  
COMPOSITE THAT ARE OPTIMAL FOR A WAFER GRINDER TABLE

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

This is in response to the Office Action dated November 14, 2005. Please amend the above-identified application as follows:

**Amendments to the claims** begin on page 2 of this paper.

**Remarks/arguments** begin on page 6 of this paper.